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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Antonius Henricus Maria Raaijmakers et al.  
Serial No.: 09/745,914  
For: ELECTRO-OPTICAL DEVICE HAVING AN ITO LAYER,  
A SiN LAYER AND AN INTERMEDIATE SILICON  
OXIDE LAYER  
Filed: December 22, 2000  
Examiner: Chung, David Y.  
Group Art Unit: 2871

Attorney Docket No.: PHN 17,819

Mail Stop: AF  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT RESPONSE**

Dear Sir:

In response to the Office Action dated October 6, 2003,  
please amend the above-noted application as follows:

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.